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| APPLICATION NUMBER | FILING OR 371(c) DATE | FIRST NAMED APPLICANT | ATTY. DOCKET NO./TITLE |
|--------------------|-----------------------|-----------------------|------------------------|
| 10/587,427 | 07/26/2006 | Eri Tsukada | Serie 6497 |

CONFIRMATION NO. 8166

40582
AIR LIQUIDE
Intellectual Property
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Title: Method for producing silicon nitride films and silicon oxynitride films by chemical vapor deposition

Publication No. US-2007-0160774-A1

Publication Date: 07/12/2007

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